

Notice of References Cited

Application/Control No.

10/676,472

Applicant(s)/Patent Under

Reexamination

PINARBASI, MUSTAFA MICHA

Examiner

Paul D. Kim

Art Unit

3729

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,421,212	07-2002	Gibbons et al.	360/327.31
*	B	US-6,153,062	11-2000	Saito et al.	204/192.2
*	C	US-5,959,810	09-1999	Kakihara et al.	360/324.12
*	D	US-2004/0047087 A1	03-2004	Fukui et al.	360/324.12
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11354860 A	12-1999	Japan	HIGAMI et al.	
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Tunnel-valve and spin-valve structures with in situ in-stack bias"; childress, J.R.; Ho, M.; Fontana, R.E.; Rice, P.M.; Carey, M.J.; Gurney, B.A.; Tsang, C.; Magnetics Conference, 2002. INTERMAG Europe 2002; 28 April-2 May 2002; Page:CA8.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.